PROCEEDINGS OF SPIE

Optics and Measurement International Conference 2019

Jana Kovačičinová Editor

8–10 October 2019 Liberec, Czech Republic

Sponsored by asphericon GmbH (Germany)
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Published by SPIE

Volume 11385

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Author(s), "Title of Paper," in *Optics and Measurement International Conference* 2019, edited by Jana Kovačičinová, Proceedings of SPIE Vol. 11385 (SPIE, Bellingham, WA, 2019) Seven-digit Article CID Number.

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510635470

ISBN: 9781510635487 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445 SPIE.org

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